



University of Iowa Microfabrication Facility (UIMF)
User Fees FY19 Academic and External rates

Wet-Processing and Metrology Lab (IATL170)

Any tools excluding Oxidation furnace: \$ 33/hr
Wet-bench: \$ 20/hr
Oxidation furnace: \$ 40/day

Thin Film, Etching and Nanoimprint Lab (IATL 174)

Cleanroom usage only: \$ 27/hr.
Cleanroom access fee: \$ 27/day (unlimited access for the day).
All tools: \$ 55/hr.
Wet-bench: \$20/hr.

Electron Beam (E-Beam) Nanolithography (IATL 172)

Cleanroom usage only: \$ 27/hr.
Cleanroom access fee: \$ 27/day (unlimited access for the day).
E-Beam Lithography: \$ 70/hr.
Raith Voyager **Imaging only**: \$ 35/hr

Staff Labor fee: \$ 85/hr

Staff Training Fees

Tool in IATL 172 (Raith Voyager): \$ 69/tool
Tools in IATL 174: \$ 39/tool
Tools and Wet-processing in IATL 170: \$ 29/tool

Penalty fees (reviewed on a case by case basis)

Failure to schedule tools on UIMF Tool scheduler prior to usage: \$ 100

Failure to keep workspace/wet-bench tidy: \$ 50

Failure to adhere to safety policies after 2nd warning: \$ 100/hr, \$ 100 minimum charge (as per the UIMF safety manual)

Important Notes:

- * Users who book tools in either IATL 172 or 174 will be automatically charged the cleanroom access fee.
- * Users will be charged the cleanroom access fee **once**, for booking tools in 172 and 174 on the same day.
- * All tool bookings are charged in 30 mins. increment and is the minimum charge, except for wet-benches, ovens and metrology tools which are 15 mins. minimum.
- * Users are not charged for using hot-plates.
- * Users will **NOT** be charged for simply swiping their card to access IATL 172 and 174 to collect items.
- * **External academic users and UI affiliated Industrial users will follow the same above charge model.**
- * **Other External industrial users will be charged at 2.5 X the academic rates.**

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